

Notice of References Cited	Application/Control No. 10/677,158		Applicant(s)/Patent Under Reexamination WANG ET AL.	
	Examiner Patricia A. George		Art Unit 1765	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0101147	05-2005	Labelle et al.	438/710
*	B	US-6,136,725	10-2000	Loan et al.	438/758
*	C	US-2005/0074983	04-2005	Shinriki et al.	438/785
*	D	US-2004/0152304	08-2004	Sarigiannis et al.	438/680
*	E	US-5,085,727	02-1992	Steger, Robert J.	156/345.47
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf; silicon Processing; Vol. 1, pg 58; para.2 1985; isbn 0-9616721-3-7
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.